	Application No.	cation No. Applicant(s)		
Notice of Allowability	09/581,663	BECKER ET AL.		
	Examiner	Art Unit		
	Shamim Ahmed	1765		
The MAILING DATE of this communication appeal All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R	(OR REMAINS) CLOSED in or other appropriate commits in the commits of the commits	n this application. If not included nunication will be mailed in due cou	rse. THIS	
1. This communication is responsive to 3/26/03.				
2. The allowed claim(s) is/are <u>32,35,39-61 and 63-69</u> .				
 3. Acknowledgment is made of a claim for foreign priority ur a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority do 	been received. been received in Applicati	on No	from the	
International Bureau (PCT Rule 17.2(a)).				
* Certified copies not received:	·			
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 4. A SUBSTITUTE OATH OR DECLARATION must be subminformal patent application (PTO-152) which give	IENT of this application. itted. Note the attached EX	AMINER'S AMENDMENT or NOT		
5. CORRECTED DRAWINGS (as "replacement sheets") mus				
(a) ☐ including changes required by the Notice of Draftspers		w (PTO-948) attached		
1) hereto or 2) to Paper No./Mail Date	<u>-</u>			
(b) ☐ including changes required by the attached Examiner' Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1			ak) af	
each sheet. Replacement sheet(s) should be labeled as such in t			JRJ OI	
6. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT	SIT OF BIOLOGICAL MAT FOR THE DEPOSIT OF BI	ERIAL must be submitted. Note OLOGICAL MATERIAL.	the .	
Attachment(s)			•	
1. Notice of References Cited (PTO-892)		nformal Patent Application (PTO-1	52)	
 Notice of Draftperson's Patent Drawing Review (PTO-948) Information Disclosure Statements (PTO-1449 or PTO/SB/0 	Paper No	6. ☑ Interview Summary (PTO-413), Paper No./Mail Date 12/14/05 7. ☑ Examiner's Amendment/Comment		
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🔲 Examiner's	s Statement of Reasons for Allowa	nce	
o biological Material	9. 🗌 Other	- Red		
		Shamim Ahmed Primary Examiner Art Unit: 1765		

EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Jong Lee (Reg. No. 36,197) on 12/14/05.

The application has been amended as follows:

IN THE SPECIFICATION:

Replace the abstract of dated 4/4/02 with the following:

"A method is proposed for etching a first silicon layer (15) that is provided with an etching mask (10) for defining lateral recesses (21). In a first plasma etching process, trenches (21) are produced in the region of the lateral recesses (21) by anisotropic etching. The first etching process comes virtually to a standstill as soon as a separating layer (12, 14, 14, 16), buried between the first silicon layer (15) and a further silicon layer (17), is reached. This separating layer is thereupon etched through in exposed regions (23, 23) by a second etching process. A subsequent third etching process then etches the further silicon layer (17, 17). In this manner, free-standing structures for sensor elements can be produced in a simple process which is completely compatible with the method steps in IC integration technology".

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IN THE CLAIMS:

Cancel claims 33,34,36,37,38 and 62 as the board of appeal decision is affirmed to Examiner on dated 8/16/05.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Shamim Ahmed whose telephone number is (571) 272-1457. The examiner can normally be reached on M-Thu (7:00-5:30) Every Friday Off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine G. Norton can be reached on (571) 272-1465. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Shamim Ahmed Primary Examiner Art Unit 1765

SA December 1, 2005